



PATENT
0020-4921P

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IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicants: M. OHTA Conf.: 8299
Appln. No.: 09/994,673 Art Unit: 1762
Filed: November 28, 2001 Examiner: T. H. MEEKS
For: METHOD FOR EVENLY COATING SEMICONDUCTOR
LASER END FACES AND FRAME USED IN THE
METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 29, 2003

Sir:

In response to the Office Action dated August 28, 2003, the period for reply petitioned to be extended one month herein to December 28, 2003 (the first business day following the holiday being December 29, 2003), the following amendments and remarks are respectfully submitted in connection with the above-identified application as follows:

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper

Remarks/Arguments begin on page 5 of this paper.